

UNITED STATES PATENT APPLICATION

FOR

A SPECTRAL METHOD FOR CALIBRATING A MULTI-AXIS  
ACCELEROMETER DEVICE

Inventors:

Vivek B. Nadkarni  
Philip Winslow

Prepared by:  
WAGNER, MURABITO & HAO, LLP  
Two North Market Street  
Third Floor  
San Jose, California 95113  
(408) 938-9060

5 This application is related to copending application "A SPECTRAL METHOD  
FOR CALIBRATING ACCELEROMETERS" by Nadkarni et al., filed on  
\_\_\_\_\_, Serial No. \_\_\_\_\_, which is incorporated herein by reference.

A SPECTRAL METHOD FOR CALIBRATING A MULTI-AXIS  
ACCELEROMETER DEVICE

10 TECHNICAL FIELD

The present invention relates generally to methods and systems for the  
precise calibration of instruments. More specifically, the present invention  
pertains to an accurate and efficient process for calibrating accelerometers.

15 BACKGROUND ART

An accelerometer is a transducer used for measuring acceleration.  
Acceleration is usually measured at a measurement point in the  
accelerometer, along a sensitive axis of the accelerometer. Generally, the  
magnitude of an applied acceleration is communicatively coupled to external  
20 instruments or circuits as an electrical impulse having amplitude proportional  
to the magnitude of the applied acceleration. The electrical impulse comprises  
the measured acceleration and is processed by the external circuits as required  
for a variety of applications. One such application is, for example, an Inertial  
Measurement Unit (IMU), where acceleration measurements are used to  
25 generate velocity and positioning information.

The electrical impulse output of an accelerometer is proportional to the  
acceleration, applied at the measurement point along the sensitive axis of the  
accelerometer. The process of calibrating an accelerometer consists of

5 computing a constant of proportionality, referred to as a scale factor of the  
accelerometer. The scale factor of an accelerometer precisely relates the  
amplitude of the electrical impulses comprising the measured acceleration to  
the magnitude of a corresponding acceleration applied at the measurement  
point, along the sensitive axis of the accelerometer.

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A multi-axis accelerometer device can measure acceleration along  
multiple sensitive axes. This can be a combination of one or more  
accelerometers, with one or more axes of sensitivity each, and a common  
frame of reference with respect to which each of these accelerometers and  
15 their respective measurement points and sensitive axes remains fixed at all  
times. The frame of reference of the multi-axis accelerometer device is the  
coordinate system in which the acceleration sensed by the array is measured.  
The frame of reference of the array is typically an orthogonal frame of  
reference.

20  
The process of calibrating a multi-axis accelerometer device consists of  
computing the scale factors for each of the multiple sensitive axes in the  
device, and furthermore computing the alignment angles of the sensitive axes  
in the device with respect to a frame of reference of the device. One measure of  
25 the alignment angles of a sensitive axis of the device is the direction cosine  
vector or alignment vector of this sensitive axis of the accelerometer device  
with respect to the orthogonal frame of reference of the array. The alignment  
vector of a sensitive axis of the multi-axis accelerometer device is the unit  
vector in the direction of the sensitive axis of the device. For optimal precision  
30 of measurement using the multi-axis accelerometer device, it is desirable to  
calibrate the multi-axis accelerometer device by precisely determining the

5 scale factors and alignment angles corresponding to each individual sensitive axis of the device.

10 Prior art systems for calibrating accelerometers (e.g., measuring and defining the scale factor) relied on comparisons of the accelerometers to certain standard devices. Such prior art systems necessarily assume that the standard devices themselves are properly calibrated, often leading to the introduction of additional error into the calibration process. For example, one prior art system (see prior art US Patent 5,970,779) requires the use of precisely controlled swing arm motor systems to which the accelerometer being tested is mounted, along with an appropriate counter weight. The swing arm motor would be precisely controlled by a processor to impart a simple harmonic motion acceleration to the sensitive axis of the accelerometer, and vary this acceleration by varying the angular acceleration of the swing arm. The resulting output of the accelerometer would be examined with respect to the controlled varying of the swing arm motor, and the scale factor would be determined therefrom.

25 One problem with the above prior art approach is that it requires a precisely controllable motor for varying the angular velocity of the accelerometer. The motor needs to precisely apply a simple harmonic acceleration to the accelerometer by varying the angular velocity about an axis of rotation. As described above, this system requires the proper calibration of the standard devices themselves (e.g., the motor), which often leads to additional error in the calibration of the accelerometer.

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5 A second, more important drawback of the above prior art approach is  
that it requires measuring the radius of rotation of the accelerometer. This  
distance can be very difficult to measure accurately, since the measurement  
point of the accelerometer is internal to the accelerometer. Any error in this  
measurement will manifest itself in through a flawed calibration.

10 Thus, what is required is a solution that accurately measures and  
determines the scale factor and alignment angles of each of the multiple  
sensitive axes in the device simultaneously. What is required is a solution that  
calibrates the multi-axis accelerometer device without introducing  
15 unnecessary sources of error. The required solution should be precise and avoid  
reliance on standard devices, which can introduce error into the calibration  
process. The required solution should not rely on any time varying control of a  
standard device to impart variable acceleration. The required solution should  
not rely on measurements of distance to points internal to the accelerometer.  
20 The present invention provides a novel solution to the above requirements.

5 DISCLOSURE OF THE INVENTION

The present invention provides a solution that accurately measures and determines the scale factor and alignment angles of multiple sensitive axes of a multi-axis accelerometer device simultaneously. The present invention provides a solution that calibrates a multi-axis accelerometer device without  
10 introducing unnecessary sources of error. The solution of the present invention is precise and avoids reliance on standard devices, which can introduce error into the calibration process. The solution of the present invention does not rely on any time varying control of a standard device to impart variable acceleration.

15 In one embodiment, the present invention is implemented as a spectral method for simultaneously determining respective scale factors and alignment vectors of a multi-axis accelerometer device for measuring acceleration. The scale factors and alignment angles are determined simultaneously in one  
20 process, allowing the calibration of the multiple axes of the multi-axis accelerometer device in one process. To measure the scale factors and alignment angles, the multi-axis accelerometer device to be calibrated is mounted on a turntable. The turntable has a tilt angle with respect to a vertical axis defined by the local gravity vector. The turntable is used to spin  
25 the multi-axis accelerometer device around an axis of rotation at an angular velocity such that each sensitive axis of the device experiences a time varying component of the local gravity vector (e.g., due to the tilt angle). The respective outputs of the multiple sensitive axes of the multi-axis accelerometer device are logged as each sensitive axis in the array experiences  
30 the time varying component of the local gravity vector. This process is repeated with the multi-axis accelerometer device placed in each of three

5 orthogonal orientations along the axes of the frame of reference of the array  
(e.g. the orthogonal X, Y and Z axes of the frame of reference).

10 The scale factors and alignment vectors of the sensitive axes of the  
multi-axis accelerometer device are determined by combining the recorded  
outputs of the multiple sensitive axes of the device mathematically with the a  
predicted output of an ideal accelerometer (e.g., a sine wave). Herein, the  
predicted output is based on the tilt angle, the angular velocity of the ideal  
accelerometer and on gravitational acceleration. This combination is  
15 performed after the multi-axis accelerometer device has been placed on the  
turntable in each of three orthogonal orientations along the axes of the frame  
of reference of the device. In so doing, the present invention accurately  
measures and determines the scale factor and alignment angles of the  
sensitive axes of the device, without relying on any time varying control of a  
standard device (e.g., stepper motor, etc.) to impart variable acceleration to  
20 the multi-axis accelerometer device. It also does not rely on a measurement of  
the radius about which the multi-axis accelerometer device rotates, and  
thereby, does not rely on a precise knowledge of the location of measurement  
point of the device internal to the device.

5 BRIEF DESCRIPTION OF THE DRAWINGS

The accompanying drawings, which are incorporated in and form a part of this specification, illustrate embodiments of the invention and, together with the description, serve to explain the principles of the invention:

10 Figure 1A shows a multi-axis accelerometer device calibration system in accordance with one embodiment of the present invention.

15 Figure 1B shows a diagram of 3 sensitive axes (e.g. A, B and C) of the multi-axis accelerometer device from Figure 1A, along with the frame of reference (e.g. axes X, Y and Z) of the multi-axis accelerometer device.

20 Figure 1C shows a diagram of the device in Orientation 1, in which the Z-axis of the frame of reference of the device is pointing along the axis of rotation of the turntable.

Figure 1D shows a diagram of the device in Orientation 1, in which the Y-axis of the frame of reference of the device is pointing along the axis of rotation of the turntable.

25 Figure 1E shows a diagram of the device in Orientation 1, in which the X-axis of the frame of reference of the device is pointing along the axis of rotation of the turntable.

30 Figure 2 shows the components of the multifunction processor in accordance with one embodiment of the present invention.



5           Figure 3 shows a flowchart of the steps of an accelerometer calibration process in accordance with one embodiment of the present invention.

          Figure 4 shows a diagram of the basic components of a computer system in accordance with one embodiment of the present invention.

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5 DETAILED DESCRIPTION OF THE INVENTION

Reference will now be made in detail to the embodiments of the invention, a spectral method for calibrating a multi-axis accelerometer device, examples of which are illustrated in the accompanying drawings. While the invention will be described in conjunction with the preferred embodiments, it will be understood that they are not intended to limit the invention to these embodiments. On the contrary, the invention is intended to cover alternatives, modifications and equivalents, which may be included within the spirit and scope of the invention as defined by the appended claims. Furthermore, in the following detailed description of the present invention, numerous specific details are set forth in order to provide a thorough understanding of the present invention. However, it will be obvious to one of ordinary skill in the art that the present invention may be practiced without these specific details. In other instances, well-known methods, procedures, components, and circuits have not been described in detail as not to unnecessarily obscure aspects of the present invention.

The present invention provides a solution that accurately measures and determines the scale factor and alignment angles of each of the multiple sensitive axes of the accelerometer device. The present invention provides a solution that can calibrate a device having multiple sensitive axes in a single calibration process. The present invention provides a solution that calibrates accelerometer devices without introducing unnecessary sources of error. The solution of the present invention is precise and avoids reliance on standard devices, which can introduce error into the calibration process. The solution of the present invention does not rely on any time varying control of a standard device to impart variable acceleration. The solution of the present invention

5 does not rely on any measurement of distance to a measurement point of the device. The present invention and its benefits are further described below.

### Notation and Nomenclature

10 Some portions of the detailed descriptions, which follow, are presented in terms of procedures, steps, logic blocks, processing, and other symbolic representations of operations on data bits within a computer memory. These descriptions and representations are the means used by those skilled in the data processing arts to convey most effectively the substance of their work to others skilled in the art. A procedure, computer-executed step, logic block, process, etc., are here, and generally, conceived to be self-consistent sequences of steps or instructions leading to a desired result. The steps are those requiring physical manipulations of physical quantities. Usually, though not necessarily, these quantities take the form of electrical or magnetic signals capable of being stored, transferred, combined, compared, and otherwise manipulated in a computer system. It has proven convenient at times, principally for reasons of common usage, to refer to these signals as bits, values, elements, symbols, characters, terms, numbers, or the like.

25 It should be borne in mind, however, that all of these and similar terms are to be associated with the appropriate physical quantities and are merely convenient labels applied to these quantities. Unless specifically stated otherwise, as apparent from the following discussions, it is appreciated that throughout the present invention, discussions utilizing terms such as "processing," "computing," "configuring," "comparing," "determining," "sampling," "transforming," or the like, refer to the action and processes of a computer system (e.g., computer system 404 of Figure 4), or similar electronic

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5 computing device, that manipulates and transforms data represented as  
physical (electronic) quantities within the computer system's registers and  
memories into other data similarly represented as physical quantities within  
the computer system registers or memories or other such information storage,  
transmission, or display devices.

#### 10 Embodiment of the Invention

Referring now to Figure 1A, a multi-axis accelerometer device  
calibration system 100 in accordance with one embodiment of the present  
invention is shown. As depicted in Figure 1A, the calibration system 100  
15 utilizes a turntable 130 and a multifunction processor system 120 to calibrate  
the output of a multi-axis accelerometer device 110. The multi-axis  
accelerometer device 110 is mounted on turntable 130 in one of three  
orientations, shown in Figure 1C, 1D and 1E, and described below. The axis of  
rotation of turntable 130 is tilted with respect to a vertical Z axis by an angle  
20  $\theta$ . The Z axis is precisely vertical, parallel to the local gravity vector,  $g$ . During  
the calibration process, the turntable rotates multi-axis accelerometer device  
110 about the axis of rotation at an angular velocity  $\omega$ . It should be noted that  
the Z axis depicted in Figure 1A refers to the vertical axis, parallel to the local  
gravity vector, as opposed to any Z axis of the multi-axis accelerometer device  
25 110.

The rotation of the turntable about the axis of rotation at the constant  
angular velocity  $\omega$  gives rise to three forces acting on the multi-axis  
accelerometer device 110, shown as  $F_1$ ,  $F_2$  and  $F_3$ .  $F_2$  is a centripetal force of  
30 constant magnitude acting on the multi-axis accelerometer device. The  
gravitational acceleration, not shown in the figure, felt by the multi-axis

5 accelerometer device in the plane of the turntable is  $g \cdot \sin(\theta)$ . Decomposing this acceleration along the radius of rotation and tangential to the radius of rotation gives us forces F1 and F3. F1 is a time varying force with amplitude  $g \cdot \sin(\theta) \cdot \cos(\phi(t))$  acting radially on the multi-axis accelerometer device, and F3 is a time varying force with amplitude  $g \cdot \sin(\theta) \cdot \sin(\phi(t))$ , acting tangentially on  
10 the multi-axis accelerometer device. Here  $\theta$  is the angle of tilt of the axis of rotation from the vertical (e.g., the Z axis), as shown in Figure 1A.  $\phi$  is the angle subtended at the axis of rotation by the frame of reference of the multi-axis accelerometer device 110 and the component of gravity in the plane of rotation of the accelerometer 110.  $\phi$  is a function of time  $t$ .  $g$  is the  
15 acceleration due to gravity. The angular velocity  $\omega = d\phi/dt$ . Specifically,  $\phi(t) = \omega \cdot t + \phi(0)$ , where  $\phi(0)$  is the value of the angle  $\phi$  at time  $t=0$ , which is when data logging begins.

Referring now to Figure 1B, the multi-axis accelerometer device in this  
20 embodiment consists of three accelerometers A, B and C, which are oriented in a fixed orientation with respect to each other. Typically, these accelerometers A, B and C are nominally mutually orthogonal. Any mounting error present is compensated for when the alignment angles of the accelerometer are computed. Additionally, the multi-axis accelerometer device has an orthogonal  
25 frame of reference with respect to which it measures acceleration. Each of the accelerometers A, B and C are also oriented in a fixed orientation with respect to this orthogonal frame of reference. Typically, the axes of the orthogonal frame of reference of the multi-axis accelerometer device (e.g. X, Y and Z axes of the device) nominally coincide with the sensitive axes of the three  
30 accelerometers. Thus, accelerometer A is aligned to point in the X direction of the multi-axis accelerometer device, but is not perfectly aligned. Similarly,

5 accelerometer B and C are aligned, but not perfectly, to respectively point  
along the Y and Z axes of the orthogonal frame of reference of the multi-axis  
accelerometer device 110. It is necessary to determine the alignment angles of  
the accelerometers, because the accelerometers A, B and C are not perfectly  
aligned with the orthogonal frame of reference of the multi-axis accelerometer  
10 device.

Referring again to Figure 1B, the multi-axis accelerometer device 110 is  
shown with its multiple sensitive axes (e.g., along the arrows A, B and C) which  
are the sensitive axes of the individual accelerometers (e.g., accelerometers A,  
15 B and C) in the device. As shown in Figure 1B, the multi-axis accelerometer  
device 110 includes three sensitive axes of measurement. The multiple axes  
are nominally mutually orthogonal, and are used to provide acceleration  
measurements, and position derived therefrom, in 3D space. Each axis has its  
corresponding output, shown as  $V_A$ ,  $V_B$  and  $V_C$ . In the present embodiment, the  
20 outputs convey the measured acceleration as voltage signals. A connector C1  
couples these output voltages  $V_A$ ,  $V_B$  and  $V_C$  from the multi-axis accelerometer  
device 110 to the multifunction processor 120 as depicted in Figure 1A. In this  
embodiment, a connector C2 connects the multifunction processor system 120  
to turntable 130 to receive information regarding the angular velocity  $\omega$ .

25 Referring now to Figures 1C, 1D and 1E, these figures show the multi-  
axis accelerometer device positioned in each of three orientations. In  
Orientation 1, shown in Figure 1C, the Z-axis of the multi-axis accelerometer  
device is parallel to the Axis of Rotation of the turntable, and the X-axis of the  
30 multi-axis accelerometer device is aligned radially, pointing along the direction  
of force F1. In Orientation 2, shown in Figure 1D, the Y-axis of the multi-axis

5 accelerometer device is parallel to the Axis of Rotation of the turntable, and  
the X-axis of the multi-axis accelerometer device is aligned radially, pointing  
along the direction of force F1. In Orientation 3, shown in Figure 1E, the X-axis  
of the multi-axis accelerometer device is parallel to the Axis of Rotation of the  
turntable, and the Z-axis of the multi-axis accelerometer device is aligned  
10 radially, pointing along the direction of force F1.

To perform the calibration, the multi-axis accelerometer device is  
positioned in Orientation 1, and rotated on the turntable. In this orientation  $\phi(t)$   
 $= \omega * t + \phi_1$  where  $\phi_1$  is the value of the angle  $\phi$  at time  $t=0$ , which is when data  
15 logging begins in Orientation 1. The voltages of each of the three  
accelerometers in the device are logged, while the turntable is rotating. This is  
repeated with the multi-axis accelerometer device in Orientations 2 and 3.  
Thus for Orientation 2,  $\phi(t) = \omega * t + \phi_2$ , where  $\phi_2$  is the value of the angle  $\phi$  at  
time when data logging begins in Orientation 2 and similarly the equation for  
20 orientation 3 is  $\phi(t) = \omega * t + \phi_3$ , where  $\phi_3$  is the value of the angle  $\phi$  at time data  
logging begins for Orientation 3.

In Orientation 1, the voltage output, denoted  $V_{A,1}$ , of the accelerometer  
A in multi-axis accelerometer device 110 (e.g., corresponding to the  
25 acceleration measured by accelerometer A) is equal to the sum of the  
accelerations due to forces F1, F2 and F3 acting on accelerometer A. The  
acceleration due to force F1 on accelerometer A is  $\alpha_A * g * \sin(\theta) * A_x * \cos(\phi(t))$ ,  
where  $\alpha_A$  is the scale factor of the accelerometer A in multi-axis accelerometer  
device 110, and  $[A_x, A_y, A_z]$  is the alignment vector of accelerometer A in the  
30 frame of reference of the multi-axis accelerometer device 110. Similarly, the  
acceleration due to force F3 on accelerometer A is  $\alpha_A * g * \sin(\theta) * A_y * \sin(\phi(t))$ . We

5 denote the constant acceleration acting on accelerometer A (e.g., due to the constant force F2, and due to the constant component of gravitational acceleration parallel to the axis of rotation) by the constant  $K_{A,1}$ . Thus,

$$V_{A,1} = \alpha_A * g * \sin(\theta) * \{A_x * \cos(\phi(t)) + A_y * \sin(\phi(t))\} + K_{A,1}$$

10 Using similar notation for the other two accelerometers, we have

$$V_{B,1} = \alpha_A * g * \sin(\theta) * \{B_x * \cos(\phi(t)) + B_y * \sin(\phi(t))\} + K_{B,1}$$

$$V_{C,1} = \alpha_A * g * \sin(\theta) * \{C_x * \cos(\phi(t)) + C_y * \sin(\phi(t))\} + K_{C,1}$$

Similarly, for Orientation 2, shown in Figure 1D, we have:

15  $V_{A,2} = \alpha_A * g * \sin(\theta) * \{A_x * \cos(\phi(t)) + A_y * \sin(\phi(t))\} + K_{A,2}$

$$V_{B,2} = \alpha_A * g * \sin(\theta) * \{B_x * \cos(\phi(t)) + B_y * \sin(\phi(t))\} + K_{B,2}$$

$$V_{C,2} = \alpha_A * g * \sin(\theta) * \{C_x * \cos(\phi(t)) + C_y * \sin(\phi(t))\} + K_{C,2}$$

Also, for Orientation 3, shown in Figure 1E, we have:

20  $V_{A,3} = \alpha_A * g * \sin(\theta) * \{A_x * \cos(\phi(t)) + A_y * \sin(\phi(t))\} + K_{A,3}$

$$V_{B,3} = \alpha_A * g * \sin(\theta) * \{B_x * \cos(\phi(t)) + B_y * \sin(\phi(t))\} + K_{B,3}$$

$$V_{C,3} = \alpha_A * g * \sin(\theta) * \{C_x * \cos(\phi(t)) + C_y * \sin(\phi(t))\} + K_{C,3}$$

Referring now to Figure 2, the components of the multifunction  
 25 processor 120 in accordance with one embodiment of the present invention are shown. For clarity, the single input C1 is shown, however it should be understood that the signal C1 is comprised of the output signals of the multiple accelerometers  $V_A$ ,  $V_B$  and  $V_C$  as depicted in Figure 1B.

30 In Orientation 1, the multifunction processor 120 first uses a low pass filter 201 to filter the voltage outputs (e.g.,  $V_{A,1}$ ,  $V_{B,1}$ ,  $V_{C,1}$ ) of the multiple axis



of accelerometer 110. An analog to digital converter 202 converts the filtered signals received from low pass filter 201 into digital form. This process of low pass filtering and then performing the analog to digital conversion on the signals is referred to as sampling. The number of times a second the sampling is performed is referred to as the sampling frequency ( $f_s$ ). Low pass filter 201 is designed to block all signals that have a frequency greater than a certain frequency, referred to as the cutoff frequency of the low pass filter, but to let through, or pass, all signals that have a frequency lower than the cutoff frequency. In the present embodiment, low pass filter 201 has a cutoff frequency that is lower than  $f_s/2$ .

The computer system 404 then logs this sampled data. This logging is performed for a period of time longer than that required for multiple complete revolutions of the axis of rotation. Computer system 404 then takes a Discrete Fourier Transform (DFT) of each of the logged voltage outputs from accelerometers A, B and C. Similar low pass filtering, analog to digital conversion, data collection, and subsequent Discrete Fourier Transform is performed with the accelerometer in each of the three orientations depicted in Figures 1C, 1D and 1E.

Consider the accelerometer A, in Orientation 1. The voltage on accelerometer A is given by:

$$V_{A,1} = \alpha_A * g * \sin(\theta) * \{A_x * \cos(\phi(t)) + A_y * \sin(\phi(t))\} + K_{A,1}.$$

In the Fourier domain, all the energy in constant force F2 and the constant component of gravitational acceleration parallel to the axis of rotation, corresponding to the constant term  $K_{A,1}$ , is seen around zero frequency. Also, all the energy in the time varying forces F1 and F3,

5 corresponding to the terms  $\alpha_A * g * \sin(\theta) * A_x * \cos(\phi(t))$  and  
 $\alpha_A * g * \sin(\theta) * A_y * \sin(\phi(t))$  respectively, is seen concentrated in the discrete DFT  
bins corresponding to the frequency  $\omega$ . This can be seen as a peak in the DFT  
at the bins corresponding to the frequency  $\omega$ . Since the DFT is a linear  
operation, the amplitude of the DFT at the frequency  $\omega$  is proportional to  
10  $\alpha_A * g * \sin(\theta)$ . Where the peak value of the DFT at the frequency  $\omega$  is referred to  
as  $P_{A,1}$ , the following equation holds true:

$$P_{A,1} = \kappa * \alpha_A * g * \sin(\theta) * \exp(i * \phi_1) * (A_x - i * A_y)$$

In this equation,  $\kappa$  is a constant of proportionality obtained during the process  
of taking the DFT of the signal  $V_{A,1}$ . Similarly, the equations from the other two  
15 accelerometers in Orientation 1 are:

$$P_{B,1} = \kappa * \alpha_B * g * \sin(\theta) * \exp(i * \phi_1) * (B_x - i * B_y)$$

$$P_{C,1} = \kappa * \alpha_C * g * \sin(\theta) * \exp(i * \phi_1) * (C_x - i * C_y)$$

Using this same process the equations for the peak DFT values for  
20 Orientations 2 are:

$$P_{A,2} = \kappa * \alpha_A * g * \sin(\theta) * \exp(i * \phi_2) * (A_x + i * A_y)$$

$$P_{B,2} = \kappa * \alpha_B * g * \sin(\theta) * \exp(i * \phi_2) * (B_x + i * B_y)$$

$$P_{C,2} = \kappa * \alpha_C * g * \sin(\theta) * \exp(i * \phi_2) * (C_x + i * C_y)$$

25 Similarly, the equations for the peak DFT values for Orientations 3 are:

$$P_{A,3} = \kappa * \alpha_A * g * \sin(\theta) * \exp(i * \phi_3) * (A_z + i * A_y)$$

$$P_{B,3} = \kappa * \alpha_B * g * \sin(\theta) * \exp(i * \phi_3) * (B_z + i * B_y)$$

$$P_{C,3} = \kappa * \alpha_C * g * \sin(\theta) * \exp(i * \phi_3) * (C_z + i * C_y)$$

30 The computer system 404 also generates a sampled version of a sine  
wave internally, of amplitude  $\alpha\_nominal * g\_nominal * \sin(\theta\_measured)$ \*

5  $\cos(\phi(t))$ . This sine wave comprises the predicted output of the accelerometer  
110. Here  $\alpha_{\text{nominal}}$  is the expected scale factor of the accelerometer,  
 $g_{\text{nominal}}$  is the value of earth's gravitational acceleration at the point the  
accelerometer measurements are being taken,  $\theta_{\text{measured}}$  is the measured  
tilt of the axis of rotation, and  $\phi(t)$  is a monotonically increasing function with  
10 constant derivative ( $\omega$ ). Computer system 404 takes the DFT of this sampled  
sine wave. The energy in this sampled sine wave can also be seen in the DFT  
as a peak in the DFT bins corresponding to the frequency of the sine wave.

The energy in this sampled sine wave is also seen as a peak of this DFT  
15 at the bins corresponding to the frequency  $\omega$ . Again, since the DFT is a linear  
operation, the amplitude of the DFT at the frequency  $\omega$  is proportional to  
 $\alpha_{\text{nominal}} * g_{\text{nominal}} * \sin(\theta_{\text{measured}})$ . Where the peak value of this DFT is  
referred to as  $P_{\text{nominal}}$ , the following equation holds true:

$$P_{\text{nominal}} = \kappa * \alpha_{\text{nominal}} * g_{\text{nominal}} * \sin(\theta_{\text{measured}})$$

20 where  $\kappa$  is the same constant of proportionality found in calculating  $P_{A,1}$ .

The tilt angle  $\theta$  is measured using an accurate tilt sensor. Therefore,  
 $\theta_{\text{measured}} = \theta$ . Also,  $g_{\text{nominal}} = 9.80665 \text{ m/s}^2$  = the approximate  
acceleration due to gravity. The errors in measuring the tilt angle and gravity  
25 are negligible in comparison to the required accuracy of the scale factor and  
alignment computation, and hence, these errors are ignored.

Using this equation for  $P_{\text{nominal}}$  and the equations for the peak DFT  
values we can solve for the scale factors  $\alpha_A$ ,  $\alpha_B$ , and  $\alpha_C$  and further solve for the  
30 alignment vectors  $[A_x, A_y, A_z]$ ,  $[B_x, B_y, B_z]$  and  $[C_x, C_y, C_z]$ . One method to solve  
these equations is shown in Appendix A.

Additionally, variations of this method, requiring fewer orientations of the multi-axis accelerometer device, can be implemented. For example, variations can be made if some information about the device is known prior to taking the calibration measurements, or if lower accuracy is required in the calibration.

One example of a variation is the following. If one of the sensitive axes of the device is known to lie in the X-Y plane in the frame of reference of the device, then the alignment angles and the scale factors for this sensitive can be computed using data recorded only in orientations 1 and 2.

Another example of a variation, is the case in which one of the sensitive axes lies nominally in the X direction of the frame of reference of the device, and the accuracy requirements on the sensor are lower. Then, a similar procedure can be performed using only Orientation 1, using a combination of Orientation 1 and Orientation 2, or a combination of all three Orientations. The errors in the scale factor and alignment angles of the sensitive axis become smaller, in this example, as more orientations are used for the calibration.

Both of these variations can be solved as approximations to, or special cases of, the general solutions described in Appendix A.

Referring now to Figure 3, a flowchart showing the steps of a process in accordance with one embodiment of the present invention is shown. As depicted in Figure 3, process 300 shows the operating steps of the calibration

5 system (e.g., system 100 of Figure 1A) calibrating a multiple axis multi-axis accelerometer device (e.g., multi-axis accelerometer device 110).

Process 300 begins in step 301, in which a tilt angle of the turntable mechanism, on which the calibration of the accelerometer device is to be performed, with respect to the local gravity vector is measured. As described above, this tilt angle (e.g.,  $\theta$ ) describes a difference between an axis of rotation of the turntable and the local gravity vector (e.g., the vertical axis). In step 302, the multi-axis accelerometer device to be calibrated is mounted on the turntable mechanism. The mounting is performed such that the Z-axis of the multi-axis accelerometer device is pointing along the axis of rotation. In step 303, the turntable is spun around the axis of rotation at an angular velocity  $\omega$ . As described above, the rotation gives rise to three forces acting on the accelerometer; a centripetal force  $F_2$  of constant magnitude acting on the accelerometer, and time varying forces  $F_1$  and  $F_3$  due to components of the local gravity vector. The constant component of gravitational acceleration, acting along the axis of rotation, also acts on the accelerometer, and is not shown in the figure. A component of  $F_1$  and  $F_3$  is simultaneously experienced by each accelerometer (e.g., A, B and C) of multi-axis accelerometer device 110. In step 304, the  $V_A$ ,  $V_B$  and  $V_C$  outputs of the accelerometer device are filtered using a low pass filter. In step 305, the filtered outputs of the accelerometer device are processed through an analog to digital converter yielding respective sampled outputs of the accelerometer. In step 306, the sampled outputs of the accelerometer device are logged as the accelerometers A, B and C of the multi-axis accelerometer device experience the time varying components  $F_1$  and  $F_3$ .

5 Referring still to process 300 of Figure 3, in step 307, the multi-axis accelerometer device is detached from the turntable and remounted such that the Y axis of the device is pointing along the axis of rotation. In step 308, steps 303 to 306 are repeated with the multi-axis accelerometer device in this new orientation.

10 In step 309, the multi-axis accelerometer device is detached from the turntable and remounted such that the X-axis of the multi-axis accelerometer device is pointing along the axis of rotation. In step 310, steps 303 to 306 are repeated with the multi-axis accelerometer device in this new orientation.

15 In step 311, a predicted output of an ideal accelerometer parallel to the plane of rotation of the turntable is generated. In step 312, discrete Fourier transforms are performed on all of the logged accelerometer outputs and the predicted output of the ideal accelerometer. Hence, in step 313, the discrete  
20 Fourier transforms of each the logged outputs along with the predicted output of the ideal accelerometer are used together to determine the scale factors and alignment vectors of each of the accelerometers of the multi-axis accelerometer device.

25 In so doing, the turntable mechanism of the present invention accurately measures and determines the scale factors and alignment vectors of the multiple axis accelerometer device without relying on any time varying control of a standard device (e.g., stepper motor, etc.) to impart variable acceleration to the accelerometer. Furthermore, it determines these scale  
30 factors and alignment vectors without the knowledge of the distance to any measurement point of the multi-axis accelerometer device from any other

5 point.

Thus, the present invention provides a solution that accurately measures and determines the scale factor and alignment vector of each accelerometer in a multiple axis multi-axis accelerometer device simultaneously. The present invention provides a solution that can calibrate a device having multiple sensitive accelerometer axes in a single calibration process. The present invention provides a solution that calibrates multi-axis accelerometer devices without introducing unnecessary sources of error. The solution of the present invention is precise and avoids reliance on standard devices, which can introduce error into the calibration process. The solution of the present invention does not rely on any time varying control of a standard device to impart variable acceleration. Furthermore the solution of the present invention does not rely on a precise measurement of the distance to any measurement point multi-axis accelerometer device from any other point.

#### Computer System Environment

Figure 4 shows a diagram of the basic components of computer system 404. Within the above discussions of the present invention, certain processes and steps are discussed that are realized, in one embodiment, as a series of instructions (e.g., software program) that reside within computer readable memory units of computer system 404 and executed by the processor(s) of system 404. When executed, the instructions cause the computer system 404 to perform specific actions and exhibit specific behavior, which was described in detail above.

In general, computer system 404, used by the present invention, comprises an address/data bus 451 for communicating information, one or more central

5 processors 453 coupled with bus 451 for processing information and instructions, a  
computer readable volatile memory unit 452 (e.g., random access memory, static  
RAM, dynamic RAM, etc.) coupled with bus 451 for storing information and  
instructions for central processor(s) 453, a computer readable non-volatile  
memory unit 454 (e.g., read only memory, programmable ROM, flash memory,  
10 EPROM, EEPROM, etc.) coupled with bus 451 for storing static information and  
instructions for central processor(s) 453. Computer system 404 interfaces with  
the other components of system 100 via system interface 460. System 404 can  
optionally include a mass storage computer readable data storage device 455 ,  
such as a magnetic or optical disk and disk drive coupled with bus 451, for storing  
15 information and instructions, a display 456 for displaying information to the  
computer user, and an input output device 457 including, for example,  
alphanumeric and function keys for communicating information and command  
selections, cursor control inputs, command selections, etc.

20 The foregoing descriptions of specific embodiments of the present  
invention have been presented for purposes of illustration and description.  
They are not intended to be exhaustive or to limit the invention to the precise  
forms disclosed, and obviously many modifications and variations are possible  
in light of the above teaching. The embodiments were chosen and described in  
25 order best to explain the principles of the invention and its practical  
application, thereby to enable others skilled in the art best to utilize the  
invention and various embodiments with various modifications as are suited to  
the particular use contemplated. It is intended that the scope of the invention  
be defined by the Claims appended hereto and their equivalents.